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SC
 ** CONTINUING DATA *****

SC
 ** FOREIGN APPLICATIONS *****

JAPAN 2000-354471 11/21/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 12/03/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 18	TOTAL CLAIMS 15 ✓	INDEPENDENT CLAIMS 2 ✓
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature <i>SC</i> Initials <i>12/23/04</i>				

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TITLE

Method and apparatus for correcting inclination of IC on semiconductor wafer

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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